2817 PATENT

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Date of Signature

and Deposit: January 28, 2003

John T. Pienkos, Reg. No. 42,997

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE,

Applicant:

Application

Filed: For:

roi.

Group Arthui Examiner:

Atty. Docket No.:

Richard D. Harris

09/843,545

April 26, 2001

METHOD FOR FABRICATING AN ISOLATED MICROELECTROMECHANICAL SYSTEM (MEMS) DEVICE USING AN INTERNAL VOID

2812

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110003.97460

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§1.97 AND 1.98

Commissioner for Patents Washington, D.C. 20231

Sir:

This paper is being presented for filing in the above case pursuant to Rules 97 and 98 of the Rules of Practice. A Form PTO-1449 "Information Disclosure Statement by Applicant" is attached which lists the references cited and copies of the references are enclosed.

No additional fees for filing this paper are believed to be due. However, the Commissioner is hereby authorized to charge any additional fees due or to credit any overpayment to deposit account no. 17-0055.

Respectfully submitted,

John T. Pienkos

Reg. No. 42,997

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